

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	((gate adj stack) and (semiconductor adj substrate) and (metal adj oxide) and (nitrogen adj1 ambient)).clm.	US-PGPUB	OR	OFF	2006/01/31 15:03
L2	1	(gate and (semiconductor adj substrate) and (metal adj oxide) and (nitrogen adj1 ambient)).clm.	US-PGPUB	OR	OFF	2006/01/31 15:04

cr ✓